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\*\* CONTINUING DATA \*\*\*\*\*

*none a2*

\*\* FOREIGN APPLICATIONS \*\*\*\*\*

REPUBLIC OF KOREA 2003-16017 03/14/2003 *a2*

IF REQUIRED, FOREIGN FILING LICENSE GRANTED

\*\* 05/26/2004

|   |   |                        |                       |                            |
|---|---|------------------------|-----------------------|----------------------------|
| Foreign Priority claimed<br><input checked="" type="checkbox"/> yes <input type="checkbox"/> no<br>35 USC 119 (a-d) conditions<br>met <input checked="" type="checkbox"/> yes <input type="checkbox"/> no <input type="checkbox"/> Met after<br>allowance<br>Verified and<br>Acknowledged | STATE OR<br>COUNTRY<br>KOREA,<br>REPUBLIC<br>OF | SHEETS<br>DRAWING<br>5 | TOTAL<br>CLAIMS<br>28 | INDEPENDENT<br>CLAIMS<br>3 |
| Examiner's Signature <i>a2</i> Initials   |   |                        |                       |                            |

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## TITLE

Electron beam lithography apparatus using a patterned emitter and method of fabricating the patterned emitter

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|------------|---|---|
| FILING FEE | FEES: Authority has been given in Paper<br>No. _____ to charge/credit DEPOSIT ACCOUNT | <input type="checkbox"/> All Fees<br><input type="checkbox"/> 1.16 Fees ( Filing )<br><input type="checkbox"/> 1.17 Fees ( Processing Ext. of<br>time ) |
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